

U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/2601.P7/ISM/COPPER/ SB	Serial No. 09/687,053
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		Applicant HEY, ET AL.	
(Use several sheets if necessary)		Filing Date OCTOBER 12, 2000	Group UNKNOWN
Examiner			

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*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
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DN	A2	6,071,388	06/06/2000	Uzoh	204	297 R	05/29/1998
DN	A3	5,723,028	03/03/1998	Poris	204	231	10/19/1994
DN	A4	5,718,813	02/17/1998	Drummond, et al.	204	192.12	04/02/1993
DN	A5	5,705,223	01/06/1998	Bunkofske	427	240	12/05/1995
DN	A6	5,651,865	07/29/1997	Sellers	204	192.13	06/17/1994
DN	A7	5,625,170	04/29/1997	Poris	177	50	01/18/1994
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DN	A9	5,516,412	05/14/1996	Andricacos, et al.	204	224 R	05/16/1995
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DN	A12	5,415,890	05/16/1995	Kloiber, et al.	427	242	01/03/1994
DN	A13	5,377,708	01/03/1995	Bergman, et al.	134	105	04/26/1993

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*Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						YES	NO
<i>DN</i>	B1	WO 97/12079	04/03/1997	WIPO	C25D	5/02	N/A
<i>DN</i>	B2	WO 99/25902	05/27/1999	WIPO	C25B	13/00	N/A
<i>DN</i>	B3	WO 99/25903	05/27/1999	WIPO	C25D	5/00	N/A
<i>DN</i>	B4	WO 99/25904	05/27/1999	WIPO	C25D	5/02	N/A
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<i>DN</i>	C1 PCT International Search Report dated February 7, 2000.
<i>DN</i>	C2 Kenneth E. Pitney, "NEY Contact Manual," Electrical Contacts for Low Energy Uses, 1973. <i>no mention</i>
<i>DN</i>	C3 Verteq Online©, "Products Overview," 1996-1998, 5 pages. <i>no mention</i>

Examiner *Donald R. Valentine*Date Considered *4/02*

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DN	A1	5,368,711	11/29/1994	Poris	204	193	04/29/1993	
DN	A2	5,349,978	09/27/1994	Sago, et al.	134	153	06/04/1993	
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DN	A4	5,316,974	05/31/1994	Crank	437	190	04/30/1990	
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*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
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DN	B2	JP 6017291	01/25/1994	JAPAN Abstract	C25D	7/12	X	
DN	B3	JP 04131395	05/06/1992	JAPAN Abstract	C25D	5/34	X	
DN	B4	JP 04280993	10/06/1992	JAPAN Abstract	C25D	5/18	X	
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DN	C1	Lucio Colombo, "Wafer Back Surface Film Removal," Central R&D, SGS-THOMPSON, Microelectronics, Agrate, Italy, 6 pages. <i>no date</i>						
DN	C2	Semitool©, Inc., "Metallization & Interconnect," 1998, 4 pages. <i>no month</i>						
Examiner <i>W. Ronald R. Valentine</i>					Date Considered <i>4/09/02</i>			
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DRV	A1	5,092,975	03/03/1992	Yamamura, et al.	204	198	06/15/1989	
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DRV	A5	4,693,805	09/15/1987	Quazi	204	192.22	02/14/1986	
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DRV	B1	JP 58182823	10/25/1983	JAPAN Abstract	H01L	21/288	YES	NO
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	B3							
	B4							
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DRV	C1	Laurell Technologies Corporation, "Two control configurations available-see <u>WS 400 OR WS-400Lite.</u> " 10/19/1998, 6 pages.						
DRV	C2	Peter Singer, "Tantalum, Copper and Damascene: The Future of Interconnects," Semiconductor International, June, 1998, Pages cover, 91-92,94,96 & 98.						
DRV	C3	Peter Singer, "Wafer Processing," Semiconductor International, June, 1998, page 70.						
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	A9						
	A10						
	A11						
	A12						
	A13						

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*Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						YES	NO
	B1						
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Examiner <i>Donald R. Valentine</i>	Date Considered <i>4/02</i>
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SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		Applicant Hey, et al.	Confirmation No.:
(Use several sheets if necessary)		Filing Date October 12, 2000	Group 1741
Examiner Unknown			

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